AMENDMENTS TO THE CLAIMS

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Please cancel claims 1-5, such that the status of the claims is as follows:

1. (Canceled)	
2. (Canceled)	
3. (Canceled)	
4. (Canceled)	
5. (Canceled)	
6. (Original)	A device for moistening a material used in a cleanroom to a target saturation
level, the device comprising:	
	a chamber;
	a rack positioned in the chamber for holding the material;
	a liquid supply of a liquid;
	an applicator in the chamber for applying the liquid to the material;
	a delivery system for delivering the liquid from the supply to the applicator; and
	a control system for controlling the amount of liquid applied to the material based
	on a parameter related to the target saturation level of the material.
7. (Original)	The device of claim 6 wherein the control system controls the amount of liquid
dispensed to the material as a function of electrical conductivity of the material.	
8. (Original)	The device of claim 6 wherein the control system controls the amount of liquid
dispensed to the material as a function in mass of the material.	

- 9. (Original) The device of claim 6 wherein the control system controls the amount of liquid dispensed to the material as a function of a time duration.
- 10. (Original) The device of claim 6 wherein the rack is centrally positioned within the chamber.
- 11. (Original) The device of claim 6 wherein the applicator includes a pump for pumping the liquid under pressure and a nozzle for applying the liquid.
- 12. (Original) The device of claim 6 wherein the control system includes a pump control for controlling the amount of liquid applied to the material.
- 13. (Original) The device of claim 6 wherein the control system includes a user interface for providing a user input signal representing the target saturation level.
- 14. (Original) The device of claim 6 wherein the control system includes a feedback sensor for providing a feedback signal representing the parameter.
- 15. (Original) The device of claim 6 wherein the control system includes a shut off sensor for providing a signal to the control system to disengage from the application of liquid to the material when the chamber is in an open position.
- 16. (Original) The device of claim 6 wherein the chamber has a drain for draining excess liquid.
- 17. (Original) The device of claim 16 wherein the drain leads to a liquid collection system.
- 18. (Original) A device for moistening a material used in a cleanroom, the device comprising: a rack for holding the material; an applicator spaced from and directed toward the rack for applying a liquid to the material; and

- a control system for controlling application of liquid to the material based on a desired saturation level of the material.
- 19. (Original) The device of claim 18 wherein the applicator is movable with respect to the rack.
- 20. (Original) The device of claim 18 wherein the applicator comprises a plurality of nozzles.
- 21. (Original) The device of claim 18 wherein the plurality of nozzles has a first set of nozzles positioned above the rack and a second set of nozzles positioned below the rack.
- 22. (Original) The device of claim 18 wherein the control system controls the amount of liquid dispensed to the material as a function of conductivity of the material.
- 23. (Original) The device of claim 18 wherein the control system controls the amount of liquid dispensed to the material as a function of mass of the material.
- 24. (Original) The device of claim 18 wherein the control system controls the amount of liquid dispensed to the material as a function of time.
- 25. (Original) The device of claim 18 wherein the machine has a drainage and collection system.
- 26. (Original) A device for moistening a material used in a cleanroom to a desired saturation level, the device comprising:
 - a chamber;
 - a rack positioned in the chamber for holding the material;
 - an applicator for applying liquid to the material;
 - a user interface for providing a user input signal;
 - a feedback system for providing a feedback signal which is a function of the saturation level of the material; and

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a control system for controlling the amount of liquid applied to the material as a function of the user input signal and the feedback signal.

27. (Original) The device of claim 26 further comprising a pressure applicator for applying pressure to the material to reduce liquid content of the material.